



MAASAI MARA UNIVERSITY

REGULAR UNIVERSITY EXAMINATIONS

2022/2023 ACADEMIC YEAR

MASTERS SECOND SEMESTER

**SCHOOL OF PURE, APPLIED AND HEALTHY
SCIENCES**

**MASTER OF SCIENCE IN PHYSICS (RENEWABLE
ENERGY AND ELECTRONICS)**

COURSE CODE: PHY 8209

**COURSE TITLE: SEMICONDUCTOR PHYSICS
AND DEVICES**

DATE: 25/4/2023

TIME: 0830-1130 HRS

INSTRUCTIONS TO CANDIDATES

1. Answer Question **ONE** and any other **Two** questions

*This paper consists of **four** printed pages. Please turn over.*

Question one [30 Marks]

- a. Define the following terms [5marks]
- Electronic structure
 - Doping
 - Phonons
 - Hall effect
 - Valence electrons
- b. Consider an n-channel GaAs MESFET at $T=300$ K with a gold contact. Assume the barrier height is 0.89 V. The n-channel doping is $2 \times 10^{15} \text{ cm}^{-3}$ and the channel thickness is $0.6 \mu\text{m}$. Calculate the pinch-off voltage and the built-in potential. The dielectric of GaAs is 12.4 . (Take charge of electron $q= 1.6 \times 10^{19} \text{ C}$, $kT/q = 0.026$ and $N_C = 4.7 \times 10^{17} \text{ cm}^{-3}$). [4marks]
- c. Explain Pauli exclusion principle. [2marks]
- d. With suitable diagrams, distinguish between intrinsic and extrinsic semiconductor. [4marks]
- e. State three main advantages of semiconductor memories [3marks]
- f. State two differences and two similarities between the JFET and MESFET. [4marks]
- g. Draw a well ladled diagram of the structure of thin film solar cell. [4marks]
- h. A silicon ingot is doped with 10^{16} arsenic atoms/ cm^3 . Find the carrier concentration and the fermi level at room temperature (300 K). (take $n_i = 9.65 \times 10^9$). [4marks]

QUESTION TWO [20 MARKS]

- (a). (i) Describe the term defect engineering [2marks]
(ii) Explain two types of defect engineering [4marks]
- (b) Calculate the mean free time of an electron having a mobility of $1000 \text{ cm}^2/\text{V-s}$ at 300K ; also calculate the mean free path. Assume $m_n = 0.26 m_n$ in these calculations. (Take $m_n = 0.91 \times 10^{-30} \text{ kg}$, charge of electron $q= 1.6 \times 10^{19} \text{ C}$ and thermal velocity of electrons at room temperature to be 10^7 cm/s). [4marks]
- (c) Show that Boltzmann transport equation is given as; [6marks]

$$\frac{\partial f}{\partial t} = -\frac{1}{\hbar} \vec{F}_{\text{ext}} \cdot \nabla_{\vec{k}} f - \vec{v} \cdot \nabla_{\vec{r}} f + \left. \frac{\partial f}{\partial t} \right|_{\text{collisions}}$$

where symbols have their usual meaning.

- (d) With suitable examples, differentiate between volatile and non-volatile memory [4marks]

QUESTION THREE [20MARKS]

- (a) Briefly describe the formation of a P-N junction [4marks]
- (b) (i) Describe the band gap theory of semiconductors [4marks]
- (ii) With the help of a well-labeled diagram, explain the direct and indirect band gap. [6marks]
- (c) Describe two types of metal-semiconductor contacts. [4marks]
- (d) State and explain two types of charge carriers. [2marks]

QUESTION FOUR [20MARKS]

- (a) State and explain three types of photonic devices. [6marks]
- (b) Discuss two applications of LEDs [4marks]
- (c) What is Quantum Efficiency as used in photodiodes? [2marks]
- (d) State two applications of MOSFETs. [2marks]
- (e) Differentiate between cathodoluminescence and radioluminescence [2marks]
- (f) Draw a diagram to illustrate processes of intrinsic photoexcitation from band to band, and extrinsic photoexcitation [4marks]

QUESTION FIVE [20MARKS]

- (a) State three challenges that inhibit commercialization of perovskite solar cells [3marks]
- (b) Briefly discuss three generations of solar cells. [6marks]

- (c) A sample of Si is doped with 10^{16} phosphorus atoms/cm³. Find the Hall voltage in the sample with $W=500\ \mu\text{m}$, $A=2.5\times 10^{-3}\ \text{cm}^2$, $I=1\ \text{mA}$, and $B_z=10^{-4}\ \text{Wb/cm}^2$. [4marks]
- (d) What is a semiconductor laser? Explain how optical amplification is achieved in a semiconductor laser [3marks]
- (e) Different between Quantum-Effect Devices and Hot-Electron Devices.[2marks]
- (f) What is a Heterojunction photodiode? [2marks]

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